	Application No.	Applicant(s)
Notice of Allowability	10/798,078	NAKANISHI ET AL.
	Examiner	Art Unit
	Toan Ton	2871
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED or other appropriate comr GHTS. This application is	in this application. If not included nunication will be mailed in due course. THIS
1. This communication is responsive to		
2. ☑ The allowed claim(s) is/are <u>9</u> .		
3. The drawings filed on 11 March 2004 are accepted by the Examiner.		
4. Acknowledgment is made of a claim for foreign priority una All b) Some* None None Of the: 1. Certified copies of the priority documents have Certified copies of the priority documents have Some* Copies of the certified copies of the priority documents have Certified copies of the priority documents have Some* Certified copies of the priority documents have Some* Certified copies of the priority documents have Certified copies of the certified copies of the priority documents have Certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Certified copies of the priority documents have Certified copi	been received. been received in Applicate cuments have been received of this communication to fixed. Note the attached Expression why the oath to be submitted. on's Patent Drawing Reviews	ion No. 10/263257. ed in this national stage application from the le a reply complying with the requirements (AMINER'S AMENDMENT or NOTICE OF or declaration is deficient.
1) hereto or 2) to Paper No./Mail Date(b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the paper of the	84(c)) should be written on he header according to 37 C	the drawings in the front (not the back) of FR 1.121(d).
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT		
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date	6. ☐ Interview Paper No 8), 7. ☐ Examiner	nformal Patent Application (PTO-152) Summary (PTO-413), ./Mail Date s Amendment/Comment s Statement of Reasons for Allowance

REASONS FOR ALLOWANCE

1. Claim 9 is allowed.

The following is an examiner's statement of reasons for allowance: the prior art of record does not anticipate nor render obvious to one ordinary skilled in the art a method of fabricating a liquid crystal display (LCD) device comprising a combination of various steps as claimed, more specifically: polymerizing the monomer while applying a voltage between opposing transparent electrodes, and thereby providing a pretilt angle to the liquid crystal molecules while, at the same time, controlling the direction in which the liquid crystal molecules tilt in the presence of an applied voltage; and light irradiation for polymerizing the polymerizable monomer is performed in least two steps.

Choi ('686) discloses a method of manufacturing a ferroelectric LCD comprising polymerizing the monomer while applying a voltage between opposing transparent electrodes. However, Choi fails to disclose 'polymerizing the monomer while applying a voltage between opposing transparent electrodes, and thereby providing a pretilt angle to the liquid crystal molecules while, at the same time, controlling the direction in which the liquid crystal molecules tilt in the presence of an applied voltage; and light irradiation for polymerizing the polymerizable monomer is performed in least two steps'.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

2. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Contact Information

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Toan Ton whose telephone number is (571) 272-2303

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

August 20, 2004

TOANTON PRIMARY EXAMINER